

BS EN 62047-22:2014



BSI Standards Publication

Semiconductor devices — Micro-electromechanical devices

Part 22: Electromechanical tensile test
method for conductive thin films on
flexible substrates

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National foreword

This British Standard is the UK implementation of EN 62047-22:2014. It is identical to IEC 62047-22:2014.

The UK participation in its preparation was entrusted to Technical Committee EPL/47, Semiconductors.

A list of organizations represented on this committee can be obtained on request to its secretary.

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Amendments/corrigenda issued since publication

Date	Text affected
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